Search Notes



Application/Control No.	Applicant(s)/Patent Under Reexamination
10567070	VAN DUUREN, MICHIEL JOS
Examiner	Art Unit
Lappas, Jason	2827

		SEARCHED		
Class		Subclass	Date	Examiner
365	210		2/22/2007	JL

SEARCH NOTES			
	Search Notes	Date	Examiner
East		2/22/2007	JL

	INTERFERENCE SEARCH			
Class	Subclass	Date	Examine	